



a below-named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated next to my name. I believe I am an original, first and joint inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled: METHOD OF DEPOSITING METAL FILM AND METAL DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL DRYING/CLEANING MODULE. The specification of which was filed on April 24, 2001 as U.S. application serial No.: 09/841,800. I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims, as amended by any amendment referred to above. I acknowledge the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations, Section 1.56(a).

I hereby claim foreign priority benefits under Title 35, United States Code, § 119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

					Priority	/ Claim
Prior Foreign Application(s)					Yes	No
Number	Country		Day/Month/Ye	ear Filed		
I hereby claim the benefit under Title 35, Unatter of each of the claims of this applica paragraph of Title 35, United States Code, Regulations, § 1.56(a) which occurred betwapplication:	tion is not disclosed § 112. I acknowledge	in the prior United State the duty to disclose m	s application in tage	he manner provide on as defined in Tit	d by the first le 37. Code o	f Federal
Application Serial No.		Filing Date		Status: Patented, Pending, Abando		
I hereby claim the benefit under Title 35, U	Jnited States Code, §	119(e) of any United S	tates provisional	application(s) liste	d below:	
60/199,580		April 25, 2000				
Application Serial No.		Filing Da	te			
I hereby appoint the following as my attornand Trademark Office in connection therev		of substitution to prosec	cute this applicati	on and transact all	business in the	ne Patent
Thomas B. Haverstock Michael J. O'Connell, Jr.	32,571 42,950	Jonathan O. Owens	37,9	02		
Please direct all correspondence regarding	this application to th	ne following:				
Thomas B. Haversto HAVERSTOCK & (260 Sheridan Avenu Palo Alto, California	OWENS LLP ne, Suite 420					
I hereby declare that all statements made helieved to be true; and further that these s punishable by fine or imprisonment or both jeopardize the validity of the application of	tatements were made h, under Section 100	e with the knowledge the 1 of Title 18 of the Unit	at willful false sta	itements and the lil	ke so made ar	e
Full Name of First Joint Inventor: Maximi	ilian A. Biberger	,				
Inventor's Signature:	1. 1	2/2		08)	/10/	0/
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Full Name of Second Joint Inventor: Paul	E. Schilling					
$Q \setminus C$	12					
Inventor's Signature: Yal Zu	n,		, - 1,-	AUG 1	0, 2001 Date	
Residence: 8407 Seeno Avenue, Granite E Citizenship: United States	Bay, California 9574	16			- Date	
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